



Stochastic IMT (Insulator-Metal-Transition) Neurons: An Interplay of Thermal and Threshold Noise at Bifurcation

Abhinav Parihar^{1*}, Matthew Jerry², Suman Datta² and Arijit Raychowdhury^{1*}

¹ School of Electrical and Computer Engineering, Georgia Institute of Technology, Atlanta, GA, United States, ² Department of Electrical Engineering, University of Notre Dame, Notre Dame, IN, United States

OPEN ACCESS

Edited by:

Themis Prodromakis,
University of Southampton,
United Kingdom

Reviewed by:

Adnan Mehonic,
University College London,
United Kingdom
Rune W. Berg,
University of Copenhagen, Denmark

*Correspondence:

Abhinav Parihar
aparihar6@gatech.edu
Arijit Raychowdhury
arijit.raychowdhury@ece.gatech.edu

Specialty section:

This article was submitted to
Neuromorphic Engineering,
a section of the journal
Frontiers in Neuroscience

Received: 25 August 2017

Accepted: 15 March 2018

Published: 04 April 2018

Citation:

Parihar A, Jerry M, Datta S and
Raychowdhury A (2018) Stochastic
IMT (Insulator-Metal-Transition)
Neurons: An Interplay of Thermal and
Threshold Noise at Bifurcation.
Front. Neurosci. 12:210.
doi: 10.3389/fnins.2018.00210

Artificial neural networks can harness stochasticity in multiple ways to enable a vast class of computationally powerful models. Boltzmann machines and other stochastic neural networks have been shown to outperform their deterministic counterparts by allowing dynamical systems to escape local energy minima. Electronic implementation of such stochastic networks is currently limited to addition of algorithmic noise to digital machines which is inherently inefficient; albeit recent efforts to harness physical noise in devices for stochasticity have shown promise. To succeed in fabricating electronic neuromorphic networks we need experimental evidence of devices with measurable and controllable stochasticity which is complemented with the development of reliable statistical models of such observed stochasticity. Current research literature has sparse evidence of the former and a complete lack of the latter. This motivates the current article where we demonstrate a stochastic neuron using an insulator-metal-transition (IMT) device, based on electrically induced phase-transition, in series with a tunable resistance. We show that an IMT neuron has dynamics similar to a piecewise linear FitzHugh-Nagumo (FHN) neuron and incorporates all characteristics of a spiking neuron in the device phenomena. We experimentally demonstrate spontaneous stochastic spiking along with electrically controllable firing probabilities using Vanadium Dioxide (VO₂) based IMT neurons which show a sigmoid-like transfer function. The stochastic spiking is explained by two noise sources - thermal noise and threshold fluctuations, which act as precursors of bifurcation. As such, the IMT neuron is modeled as an Ornstein-Uhlenbeck (OU) process with a fluctuating boundary resulting in transfer curves that closely match experiments. The moments of interspike intervals are calculated analytically by extending the first-passage-time (FPT) models for Ornstein-Uhlenbeck (OU) process to include a fluctuating boundary. We find that the coefficient of variation of interspike intervals depend on the relative proportion of thermal and threshold noise, where threshold noise is the dominant source in the current experimental demonstrations. As one of the first comprehensive studies of a stochastic neuron hardware and its statistical properties, this article would enable efficient implementation of a large class of neuro-mimetic networks and algorithms.

Keywords: stochastic neuron, insulator-metal transition, FitzHugh-Nagumo (FHN) neuron model, Ornstein-Uhlenbeck process, threshold noise, vanadium-dioxide

1. INTRODUCTION

A growing need for efficient machine-learning in autonomous systems coupled with an interest in solving computationally hard optimization problems has led to active research in stochastic models of computing. Optimization techniques (Haykin, 2009) including Stochastic Sampling Machines (SSM), Simulated Annealing, Stochastic Gradients etc., are examples of such models. All these algorithms are currently implemented using digital hardware which first creates a mathematically accurate platform for computing, and later adds digital noise at the algorithm level. Hence, it is enticing to construct hardware primitives that can harness the already existing physical sources of noise to create a stochastic computing platform. The principal challenge with such efforts is the lack of stable or reproducible distributions, or functions of distributions, of physical noise. One basic stochastic unit which enables a systematic construction of stochastic hardware has long been known—the stochastic neuron (Gerstner and Kistler, 2002)—which is also believed to be the unit of computation in the human brain. Moreover, recent studies (Buesing et al., 2011) have demonstrated practical applications like sampling using networks of such stochastic spiking neurons. There have been some attempts for building neuron hardware (Indiveri et al., 2006; Pickett et al., 2013; Mehonic and Kenyon, 2016; Sengupta et al., 2016; Tuma et al., 2016), but building a neuron with self-sustained spikes, or oscillations, which are stochastic in nature and where the probability of firing is controllable using a signal has been challenging. Here, we demonstrate and analytically study a true stochastic neuron (Jerry et al., 2017a) which is fabricated using oscillators (Shukla et al., 2014a,b; Parihar et al., 2015) based on insulator-metal transition (IMT) materials, e.g., Vanadium Dioxide (VO₂), wherein the inherent physical noise in the dynamics is used to implement stochasticity. The firing probability, and not just the deterministic frequency of oscillations or spikes, is controllable using an electrical signal. We also show that such an IMT neuron has similar dynamics as a piecewise linear FitzHugh-Nagumo (FHN) neuron with thermal noise along with threshold fluctuations as precursors of bifurcation resulting in a sigmoid-like transfer function for the neural firing rates. By analyzing the variance of interspike interval, we determine that for the range of thermal noise present in our experimental demonstrations, threshold fluctuations are responsible for most of the stochasticity compared to thermal noise.

2. MATERIALS AND METHODS

2.1. IMT Phase Change Neuron Model

A stochastic IMT neuron is fabricated using relaxation oscillators (Shukla et al., 2014b; Parihar et al., 2015) composed of an IMT phase change device, e.g., Vanadium Dioxide (VO₂), in series with a tunable resistance, e.g., transistor (Shukla et al., 2014a) (Figure 1A). An IMT device is a two terminal device with two resistive states—insulating (I) and metallic (M), and the device transitions between the two states based on the applied electric field (which in turn changes the current through the device and the corresponding temperature) across it. The phase transitions

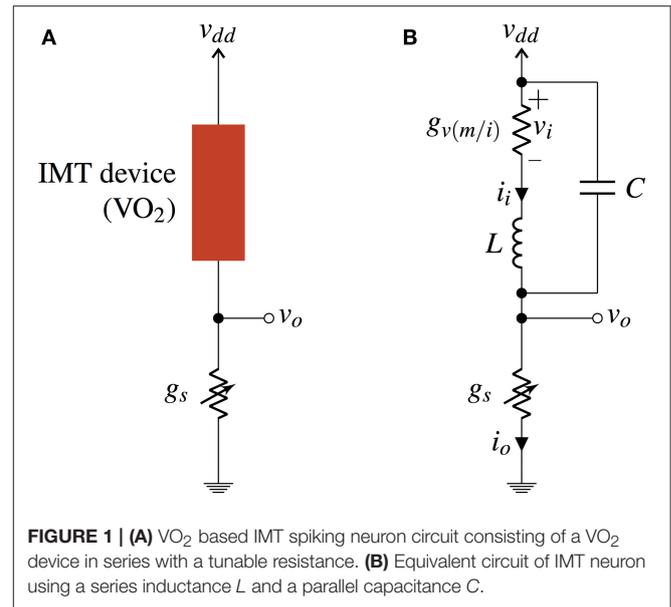


FIGURE 1 | (A) VO₂ based IMT spiking neuron circuit consisting of a VO₂ device in series with a tunable resistance. **(B)** Equivalent circuit of IMT neuron using a series inductance *L* and a parallel capacitance *C*.

are hysteretic in nature, which means that the IMT (insulator-to-metal) transition does not occur at the same voltage as the MIT (metal-to-insulator) transition. For a range of values of the series resistance, the resultant circuit shows spontaneous oscillations due to hysteresis and a lack of stable point (Parihar et al., 2015). Overall, the series resistance acts as a parameter for bifurcation between a spiking (or oscillating) state and a resting state of an IMT neuron.

The equivalent circuit model for an IMT oscillator is shown in Figure 1B with the hysteretic switching conductance $g_{v(m/i)}$ (g_{vm} in metallic and g_{vi} in insulating state), a series inductance L , and a parallel internal capacitance C . Let the IMT and MIT thresholds of the device be denoted by v_h and v_l , respectively, with $v_h > v_l$, and the current-voltage relationship of the hysteretic conductance be

$$v_i = h(i_i, s)$$

where h is linear in i_i and s is the state—metallic (M) or insulating (I).

The system dynamics is then given by:

$$\begin{aligned} L \frac{di_i}{dt} &= (v_{dd} - h(i_i, s)) - v_o \\ C \frac{dv_o}{dt} &= i_i - g_s v_o \end{aligned} \tag{1}$$

with i_i and v_o as shown in Figure 1B and s is considered as an independent variable.

2.2. Mechanism of Oscillations and Spikes

In VO₂, IMT, and MIT transitions are orders of magnitude faster than RC time constants for oscillations, as observed in frequency (Kar et al., 2013) and time-domain measurements for voltage driven (Jerry et al., 2016) and photoinduced transitions

(Cocker et al., 2012). As such, the change in resistance of the IMT device is assumed to be instantaneous. **Figure 2A** shows the phase space $i_i \times (v_{dd} - v_o)$. V-I curves for IMT device in the two states metallic (M) and insulating (I) and the load line for series conductance $v_o = i_i/g_s$ for the steady state are shown along with the fixed points of the system S_1 and S_2 in insulating and metallic states respectively. The load line and V-I curves are essentially the nullclines of v_o and i_i , respectively. The capacitance- inductance pair delays the transitions and slowly pulls the system toward the fixed points S_1 and S_2 even when the IMT device transitions instantaneously. For small L/C ratio, the eigenvector (of the coefficient matrix) with large negative eigenvalue becomes parallel to the x-axis, whereas the other eigenvector becomes parallel to AB' or BA' depending on the state (M or I). When the system approaches A from below (or B from above) and IMT device is insulating (or metallic) with fixed point S_1 (or S_2), the IMT device transitions into metallic (or insulating) state changing the fixed point to S_2 (or S_1). Two trajectories are shown starting from points A and B each for the system (Equation 1)—one for small L/C value (solid) and the other for large L/C value (dashed). After a transition, the system moves parallel to x-axis almost instantaneously and spends most of the time following the V-I curve toward the fixed point. Before the fixed point is reached the MIT (or IMT) transition threshold is encountered which switches the fixed point, and the cycle continues resulting in sustained oscillations or spike generation.

2.3. Model Approximations and Connections With FHN Neuron

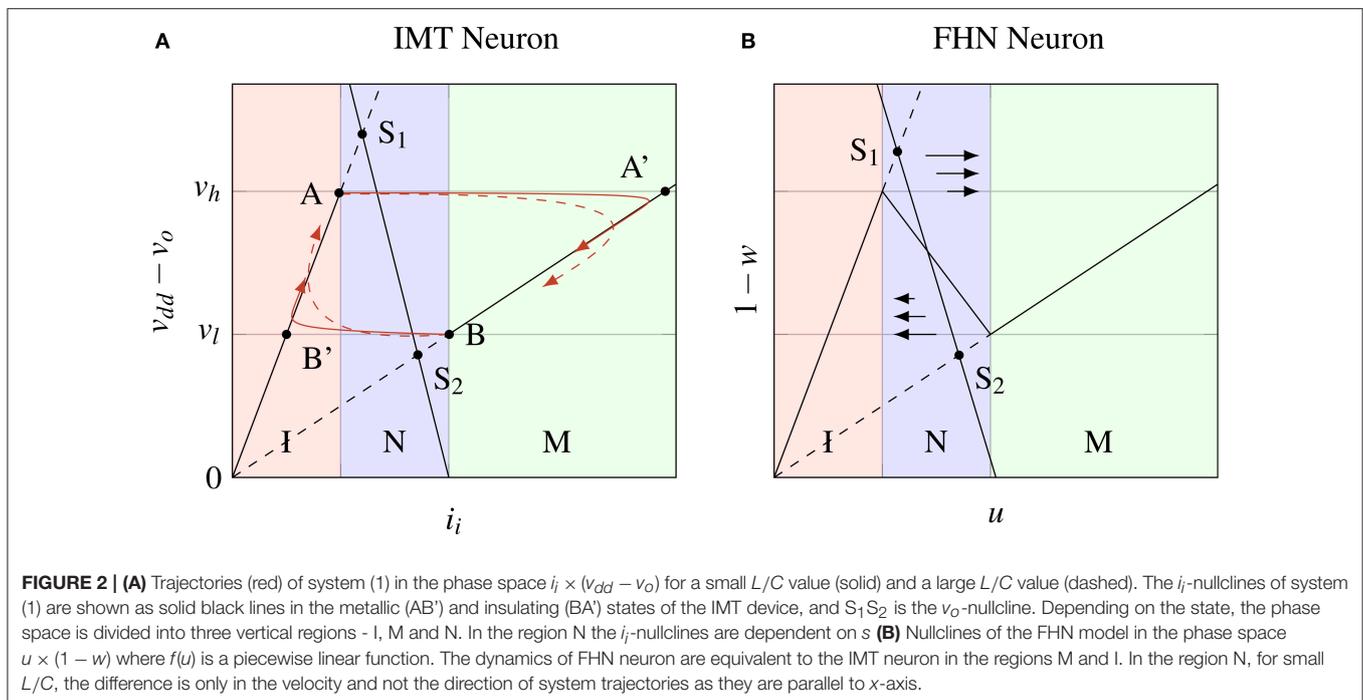
2.3.1. Non-hysteretic Approximation

The model of (Equation 1) is very similar to a piecewise linear caricature of FitzHugh-Nagumo (FHN) neuron model (Gerstner

and Kistler, 2002), also called the McKean’s caricature (McKean, 1970; Tonnelier, 2003). Mathematically, the FHN model is given by:

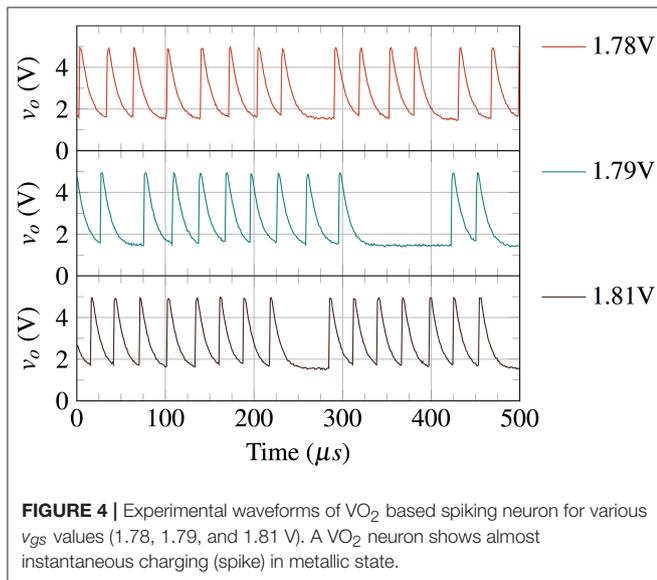
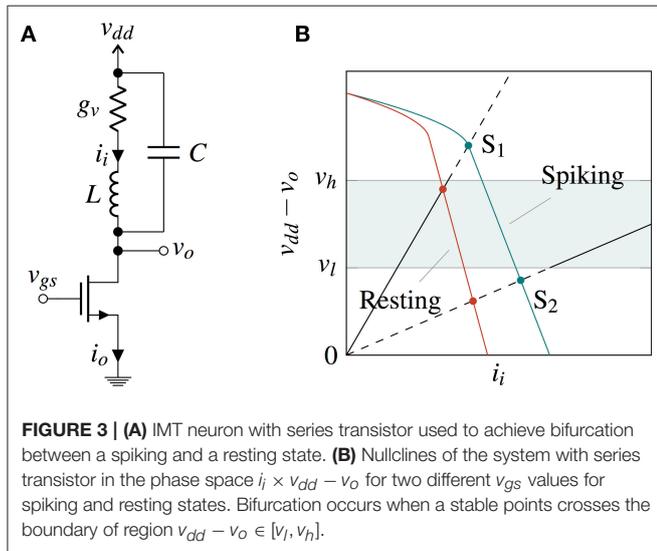
$$\begin{aligned} \frac{du}{dt} &= f(u) - w + I_{ext} \\ \tau \frac{dw}{dt} &= u - bw + a \end{aligned} \tag{2}$$

where $f(u)$ is a polynomial of third degree, e.g., $f(u) = u - u^3/3$, and I_{ext} is the parameter for bifurcation, as opposed to g_s in Equation (1). In the FHN model, one variable (u), possessing cubic nonlinearity, allows regenerative self-excitation via a positive feedback, and the second, a recovery variable (w), possessing linear dynamics, provides a slower negative feedback. It was reasoned in McKean (1970) that the essential features of FHN model are retained in a “caricature” where the cubic non-linearity is replaced by a piecewise linear function $f(u)$. Nullclines of (Equation 2) with a piecewise linear $f(u)$ are shown in **Figure 2B** in the phase space $u \times (1 - w)$. A function $f(u)$ is trivially possible such that it is equal to $v_{dd} - h(i_i, s)$ in the regions M and I, hence making the u -nullcline similar to the i_i -nullcline in those regions. In the region N, the difference between $f(u)$ and $v_{dd} - h(i_i, s)$ for any state s does not result in a difference in the direction of system trajectories but only in their velocity, because for small L/C the trajectories are almost parallel to x-axis. Bifurcation in VO_2 neuron is achieved by tuning the load line using a tunable resistance (g_s), or a series transistor (**Figure 3A**). **Figure 3B** shows two load line curves corresponding to different gate voltages (v_{gs}), where one gives rise to spikes while the other results in a resting state.



2.3.2. Single Dimensional Approximation

Moreover, a single dimensional piecewise approximation of the system can be performed using a dimensionality reduction by replacing the movement along the eigenvector parallel to the x-axis with an instantaneous transition from A to A', or B to B'. This leaves a 1-dimensional subsystem in M and I each along the V-I curves AB' and BA'. Experiments using VO₂ show that the metallic state conductance g_{vm} is very high which causes the charging cycle of v_o to be almost instantaneous (Figure 4) and resembles a spike of a biological neuron. As such, the spiking statistics can be studied by modeling just the discharge cycle of v_o . The inductance being negligible can be effectively removed and only the capacitance is needed for modeling the 1D subsystem of insulating state (Figure 6A) making $v_i = v_{dd} - v_o$.



2.4. Noise Induced Stochastic Behavior

The two important noise sources which induce stochasticity in an IMT neuron are (a) V_{IMT} (v_h) fluctuations (Zhang et al., 2016; Jerry et al., 2017b), and (b) thermal noise. Thermal noise $\eta(t)$ is modeled in the circuit (Figure 6A) as a white noise voltage $\eta(t)dt = \sigma_t dw_t$ where w_t is the standard weiner process and σ_t^2 is the infinitesimal thermal noise variance. The threshold v_h is assumed constant during a spike, but varies from one spike to another. The distribution of v_h from spike to spike is assumed to be Gaussian or subGaussian whose parameters are estimated from experimental observations of oscillations. If the series transistor always remains in saturation and show linear voltage-current relationship, as is the case in our VO₂ based experiments, the discharge phase can be described by an Ornstein-Uhlenbeck (OU) process

$$dx = \frac{1}{\theta}(\mu - x)dt + \sigma dw_t \quad (3)$$

where μ , θ , and σ are functions of circuit parameters of the series transistor, the IMT device and σ_t . The interspike interval is thus the first-passage-time (FPT) of this OU process, but with a fluctuating boundary.

2.4.1. OU Process With Constant Boundary

Analytical expressions for the FPT of OU process (with $\mu = 0$) for a constant boundary were derived using the Laplace transform method in Ricciardi and Sato (1988). Reproducing some of its results, let the first passage time for the system (Equation 3), with $\mu = 0$, which starts at $x(0) = x_0$ and hits a boundary S , be denoted by the random variable $t_f(S, x_0)$, and its m th moment by $\tau_m(S, x_0)$. Also, let $\tilde{t}_f(S, x_0)$ be the FPT for another OU process with $\mu = 0$, $\theta = 1$, and $\sigma = 2$, and $\tilde{\tau}_m(S, x_0)$ be its m th moment. Then time and space scaling for the OU process imply that

$$t_f(S, x_0) \stackrel{d}{=} \theta \tilde{t}_f(\alpha S, \alpha x_0) \\ \therefore \tau_m(S, x_0) = \theta^m \tilde{\tau}_m(\alpha S, \alpha x_0) \quad (4)$$

where $\alpha = \sqrt{\frac{2}{\theta\sigma^2}}$. The first two moments for the base case OU process $\tilde{\tau}_1$ and $\tilde{\tau}_2$ are given by

$$\tilde{\tau}_1(S, x_0) = \phi_1(S) - \phi_1(x_0) \\ \tilde{\tau}_2(S, x_0) = 2\phi_1(S)^2 - \phi_2(S) - 2\phi_1(S)\phi_1(x_0) + \phi_2(x_0) \quad (5)$$

where $\phi_k(z)$ can be written as an infinite sum

$$\phi_k(z) = \frac{1}{2^k} \sum_{n=1}^{\infty} \frac{(\sqrt{2}z)^n \Gamma(\frac{n}{2}) \rho(n, k)}{n!} \quad (6)$$

with $\rho(n, k)$ being a function of the digamma function (Ricciardi and Sato, 1988).

2.4.2. OU Process With Fluctuating Boundary

We extend this framework for calculating the FPT statistics with a fluctuating boundary S as follows. Let the IMT threshold

be represented by the random variable \mathbf{v}_h . For the VO₂ based IMT neuron, the 1D subsystem in the insulating phase can be converted in the form of Equation(3) with $\mu = 0$ by translating the origin to the fixed point. If this transformation is \mathbf{T} then $x = \mathbf{T}v_i = \mathbf{T}(v_{dd} - v_o)$, $\mathbf{S} = \mathbf{T}\mathbf{v}_h$, and $x_o = \mathbf{T}v_l$. The start and end points are B' and A, respectively in **Figure 2**. \mathbf{v}_h is assumed constant during a spike, and across spikes the distribution of \mathbf{v}_h is $\mathbf{v}_h \sim \mathcal{D}$, where \mathcal{D} is either Gaussian, or subGaussian. For subGaussian distributions we use the Exponential Power family EP[κ], κ being the shape factor. Let the interspike interval of IMT neuron be denoted by the marginal random variable $t_{\text{imt}}(\mathcal{D}, v_l)$. Then t_{imt} is related to t_f in Equation (4), given common parameters θ and σ , as follows:

$$t_{\text{imt}}(\mathcal{D}, v_l) | (\mathbf{v}_h = v) \stackrel{d}{=} t_f(\mathbf{T}v, \mathbf{T}v_l)$$

The moments of t_{imt} can be calculated as:

$$\begin{aligned} \mathbb{E}[t_{\text{imt}}(\mathcal{D}, v_l)^m] &= \mathbb{E}_{v_h}[\mathbb{E}[t_{\text{imt}}(\mathcal{D}, \mathbf{T}v_l)^m | \mathbf{v}_h = v]] \\ &= \mathbb{E}_{v_h}[\tau_m(\mathbf{T}\mathbf{v}_h, \mathbf{T}v_l)] \\ &= \theta^m \mathbb{E}_{v_h}[\tilde{\tau}_m(\alpha\mathbf{T}\mathbf{v}_h, \alpha\mathbf{T}v_l)] \end{aligned} \tag{7}$$

where $\alpha = \sqrt{\frac{2}{\theta\sigma^2}}$. If \mathcal{D} is Gaussian or EP[κ] distribution and $\alpha\mathbf{T}$ is an affine transformation, then $\alpha\mathbf{T}\mathbf{v}_h$ also has a Gaussian or EP[κ] distribution.

2.5. Experiments

IMT devices are fabricated on a 10nm VO₂ thin film grown by reactive oxide molecular beam epitaxy on (001) TiO₂ substrate using a Veeco Gen10 system (Tashman et al., 2014). Planar two terminal structures are formed by patterning contacts using standard electron beam lithography which defines the device length (L_{VO_2}). Pd (20 nm)/Au (60 nm) contacts are then deposited by electron beam evaporation and liftoff. The devices are then isolated and the widths (W_{VO_2}) are defined using a CF₄ based dry etch.

The IMT neuron is constructed using an externally connected n-channel MOSFET (ALD110802) and the fabricated VO₂ device. A prototypical I-V curve is shown in **Figure 5A**. Within the experimental data, the current is limited to an arbitrarily chosen 200 μA to prevent a thermal runaway and breakdown of the device while in the low resistance metallic state. It should be noted that as the metallic state corresponds to the abrupt charging cycle of v_o , limiting the current would not have noticeable effect on spiking statistics of the neuron.

Threshold voltage fluctuations (cycle to cycle) were observed in all devices which were tested (>10). Threshold voltage distribution was estimated using the varying cycle-to-cycle threshold voltages collected from a single device. Thermal noise is not measured directly, but is estimated approximately by matching the simulation waveforms from the circuit model (**Figure 6A**) with the observed experimental waveforms. It can be verified that thermal noise of the transistor is not the dominant noise source by measuring the threshold variation as a function of the transistor current (**Figure 5B**) and observing that the distribution of switching threshold does not change with varying transistor current. Finally, the firing rate and its variation with v_{gs} (**Figure 6B**) were measured for a single device.

3. RESULTS

3.1. Spiking Statistics

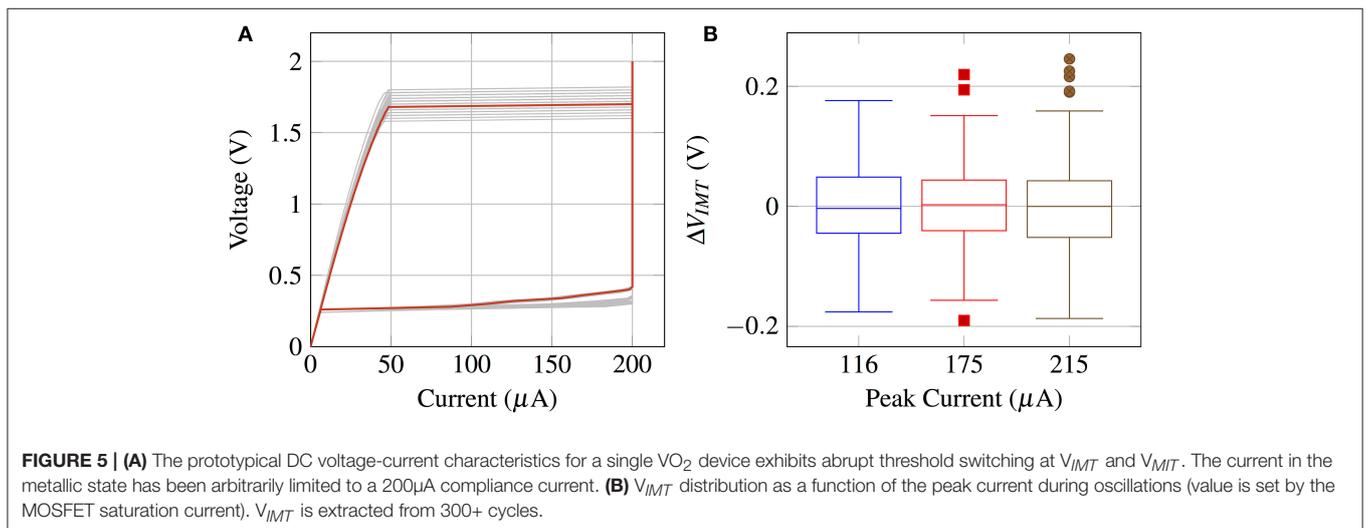
3.1.1. First Moment and the Firing Rate

First moment of t_{imt} is calculated using Equations (5) and (7) as

$$\mathbb{E}[t_{\text{imt}}(\mathcal{D}, v_l)] = \theta(\mathbb{E}_{v_h}[\phi_1(\alpha\mathbf{T}\mathbf{v}_h)] - \phi_1(\alpha x_o))$$

The expansion for $\phi_k(z)$ in Equation(6) can be used to calculate $\mathbb{E}_{v_h}[\phi_k(\alpha\mathbf{T}\mathbf{v}_h)]$ using the moments of $\alpha\mathbf{T}\mathbf{v}_h$ as follows

$$\mathbb{E}_{v_h}[\phi_k(\alpha\mathbf{T}\mathbf{v}_h)] = \frac{1}{2^k} \sum_{n=1}^{\infty} \frac{(\sqrt{2})^n \mathbb{E}[(\alpha\mathbf{T}\mathbf{v}_h)^n] \Gamma\left(\frac{n}{2}\right) \rho(n, k)}{n!}$$



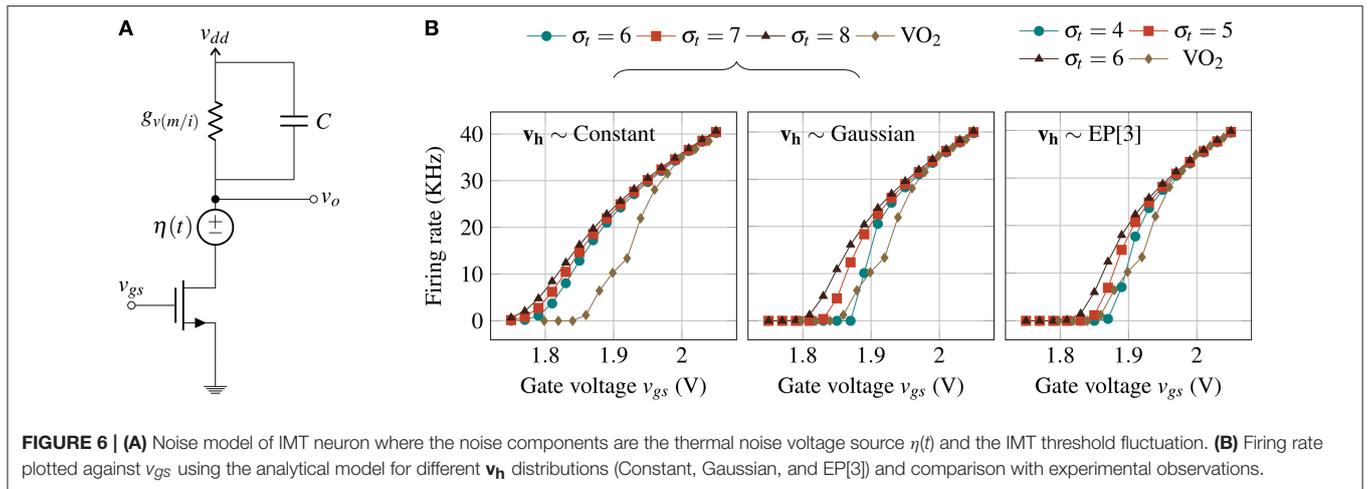


FIGURE 6 | (A) Noise model of IMT neuron where the noise components are the thermal noise voltage source $\eta(t)$ and the IMT threshold fluctuation. **(B)** Firing rate plotted against v_{gs} using the analytical model for different v_h distributions (Constant, Gaussian, and EP[3]) and comparison with experimental observations.

Figure 6B shows firing rate ($1/\mathbb{E}[\mathbf{t}_{imt}(\mathbf{D}, v_l)]$) as a function of v_{gs} for various σ_t values and for three distributions of threshold fluctuations. The calculations approximate the experimental observations well for all three v_h distributions, the closest being EP[3] with $\sigma_t = 4$.

3.1.2. Higher Moments

For higher moments, higher order terms are encountered. For example, in case of the second moment, using Equations(5) and (7), we obtain

$$\begin{aligned} \mathbb{E}_{v_h}[\tilde{\tau}_2(\alpha \mathbf{T}v_h, \alpha \mathbf{T}v_l)] &= 2\mathbb{E}_{v_h}[\phi_1(\alpha \mathbf{T}v_h)^2] - \mathbb{E}_{v_h}[\phi_2(\alpha \mathbf{T}v_h)] \\ &\quad - 2\mathbb{E}_{v_h}[\phi_1(\alpha \mathbf{T}v_h)\phi_1(\alpha \mathbf{T}v_l)] \\ &\quad + \phi_2(\alpha \mathbf{T}v_l) \end{aligned}$$

with a higher order term $\phi_1(\alpha \mathbf{T}v_h)^2$. In the case of the third moment we obtain $\phi_1(\alpha \mathbf{T}v_h)\phi_2(\alpha \mathbf{T}v_h)$. As each ϕ_k term is an infinite sum, we construct a cauchy product expansion for the higher order term using the infinite sum expansions of the constituent ϕ_k s and then distribute the expectation over addition. For example, if the ϕ_k expansions of $\phi_1(z)$ and $\phi_2(z)$ are $(\sum a_i)$ and $(\sum b_i)$, respectively, then the cauchy product expansion of $\phi_1(z)\phi_2(z)$ can be calculated as $\sum c_i$, where c_i is a function of $a_{1\dots i}$ and $b_{1\dots i}$, and the expectation $\mathbb{E}[\phi_1(z)\phi_2(z)] = \sum \mathbb{E}[c_i]$. Since c_i is a polynomial in z , $\mathbb{E}[c_i]$ can be calculated using the moments of z .

If μ_{imt} and σ_{imt} are the mean and standard deviation of interspike intervals \mathbf{t}_{imt} , the coefficient of variation (σ_{imt}/μ_{imt}) varies with the relative proportion of the thermal and the threshold induced noise. Figure 7 shows σ_{imt}/μ_{imt} (calculated using parameters matched with our VO₂ experiments) plotted against σ_t for various kinds of v_h distributions fitted to experimental observations. σ_{imt}/μ_{imt} as observed in our VO₂ experiments is about an order of magnitude more than what would be calculated with only thermal noise using such a neuron, and hence, threshold noise contributes significant stochasticity to the spiking behavior. As the IMT neuron is setup such that the stable point is close to the IMT transition point (Figure 3B), low σ_t results in high and diverging σ_{imt}/μ_{imt} for any distribution of threshold noise, and σ_{imt}/μ_{imt} reduces with increasing σ_t for

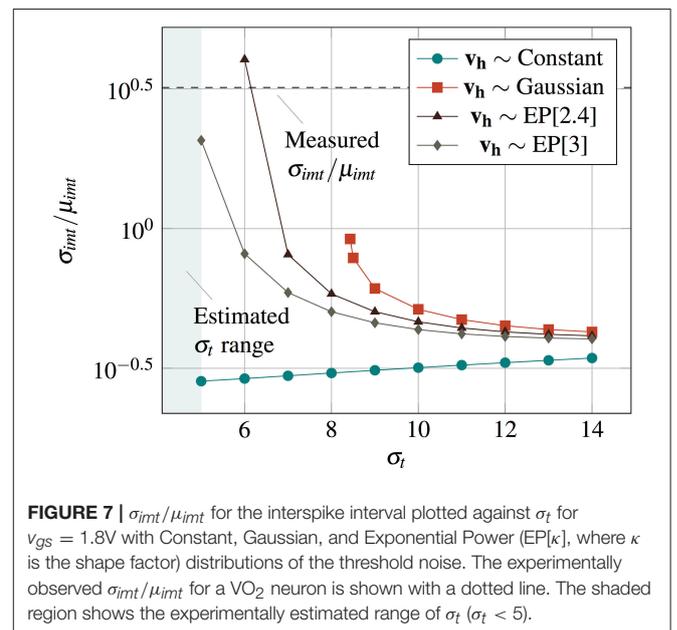


FIGURE 7 | σ_{imt}/μ_{imt} for the interspike interval plotted against σ_t for $v_{gs} = 1.8V$ with Constant, Gaussian, and Exponential Power (EP[κ], where κ is the shape factor) distributions of the threshold noise. The experimentally observed σ_{imt}/μ_{imt} for a VO₂ neuron is shown with a dotted line. The shaded region shows the experimentally estimated range of σ_t ($\sigma_t < 5$).

the range shown. For a Normally distributed v_h the variance diverges for $\sigma_t \lesssim 8$, but for Exponential Power (EP) distributions with lighter tails, the variance converges for smaller values of σ_t . Statistical measurements on experimental data, as indicated in Figure 7, provide measures of σ_{imt}/μ_{imt} (dotted line) and σ_t (shaded region). We note that EP distributions provide a better approximation of the stochastic nature of experimentally demonstrated VO₂ neurons as the range of σ_t is estimated to be < 5 .

4. DISCUSSION

In this paper, we demonstrate and analyse an IMT based stochastic neuron hardware which relies on both threshold fluctuations and thermal noise as precursors to bifurcation. The IMT neuron emulates the functionality of theoretical neuron models completely by incorporating all neuron

TABLE 1 | Comparison of this work (experimental details from Jerry et al., 2017a) with other spiking neuron hardware works based on different characteristics of spiking neurons.

	Tuma et al., 2016	Pickett et al., 2013	Sengupta et al., 2016	Indiveri et al., 2006	This work (VO ₂)
Neuron type	Integrate & Fire	Hodgkin Huxley	Integrate & Fire	Integrate & Fire	Piecewise Linear FHN
Material/Platform	Chalcogenide	Mott insulator NbO ₂	MTJ	0.35 μm CMOS	Vanadium Dioxide (VO ₂)
Material phenomenon	Phase Change	IMT	Spin transfer torque (STT)	–	IMT
Spontaneous spiking using only device	No	Yes	No	–	Yes
Peripherals needed for spiking	Yes, for spike generation and reset	No	Yes, for spike generation and reset	–	No
Integration mechanism (I&F)	Heat accumulation	–	Magnetization accumulation	Capacitor charging	Capacitor charging
Threshold mechanism (I&F)	External reset by measuring conductance	Spontaneous IMT	External reset by detecting magnet flip	Reset using comparator	Spontaneous IMT
Stochastic	Yes	–	Yes	No	Yes
Kind of stochasticity (I&F)	Reset potential	–	Differential	–	Threshold and differential
Source of stochasticity / noise	Melt-quench process	–	Thermal noise	–	IMT threshold fluctuations & Thermal noise
Control of stochastic firing rate	Only integration rate	–	Only integration rate	Only integration rate	Yes
Status of experiments	Constant stochasticity, variable integration rate	Deterministic spiking	None	Deterministic spiking	Sigmoidal variation of stochastic firing rates
Peak current	750–800 μA	–	–	–	200 μA
Power or Energy/spike	120 μW	–	–	900 pJ / spike	196 pJ / spike
Voltage	5.5 V	1.75 V	–	3.3 V	0.7 V
Maximum firing rates	35–40 KHz	30 KHz	–	200 Hz	30 KHz

characteristics into device phenomena. Unlike other similar efforts, it does not need peripheral circuits alongside the core device circuit (an IMT device and a transistor) to emulate any sub-component of the spiking neuron model like thresholding, reset etc. Moreover, the neuron construction not only utilizes inherent physical noise sources for stochasticity, but also enables control of firing probability using an analog electrical signal—the gate voltage of series transistor. This is different from previous works which control only the deterministic aspect of firing rate like the charging rate. A comparison of spiking neuron hardware characteristics in different works is shown in **Table 1**.

We also show that the neuron dynamics follow a linear “carricature” of the FitzHugh-Nagumo model with intrinsic stochasticity. The analytical models developed in this paper can also faithfully reproduce the experimentally observed transfer curve which is a stochastic property. Such analytical verification of stochastic neuron experiments is one of the first in this work. It is an important result as it indicates reproducibility of stochastic characteristics and helps in creating the pathway toward perfecting these devices. With a growing consensus that stochasticity will play a key role in solving hard computing tasks, we need efficient ways for controlled amplification and conversion of physical noise into a readable

and computable form. In this regard, the IMT based neuron represents a promising solution for a stochastic computational element. Such stochastic neurons have the potential to realize bio-mimetic computational kernels that can be employed to solve a large class of optimization and machine-learning problems.

AUTHOR CONTRIBUTIONS

AP worked on the development of theory, simulation frameworks, and mathematical models; MJ worked on the experiments; AR advised AP and participated in the problem formulation; SD advised MJ and also participated in the design of experiments and problem formulations.

ACKNOWLEDGMENTS

This project was supported by the National Science Foundation under grants 1640081, Expeditions in Computing Award-1317560 and CCF- 1317373, and the Nanoelectronics Research Corporation (NERC), a wholly-owned subsidiary of the Semiconductor Research Corporation (SRC), through Extremely Energy Efficient Collective Electronics (EXCEL), an SRC-NRI Nanoelectronics Research Initiative under Research Task IDs 2698.001 and 2698.002.

REFERENCES

- Buesing, L., Bill, J., Nessler, B., and Maass, W. (2011). Neural dynamics as sampling: a model for stochastic computation in recurrent networks of spiking neurons. *PLoS Comput. Biol.* 7:e1002211. doi: 10.1371/journal.pcbi.1002211
- Cocker, T., Titova, L., Fourmaux, S., Holloway, G., Bandulet, H.-C., Brassard, D., et al. (2012). Phase diagram of the ultrafast photoinduced insulator-metal transition in vanadium dioxide. *Phys. Rev. B* 85:155120. doi: 10.1103/PhysRevB.85.155120
- Cotter, W., and Kistler, W. M. (2002). *Spiking Neuron Models: Single Neurons, Populations, Plasticity*. Cambridge: Cambridge university press.
- Haykin, S. S. (2009). *Neural Networks and Learning Machines*. Prentice Hall.
- Indiveri, G., Chicca, E., and Douglas, R. (2006). A VLSI array of low-power spiking neurons and bistable synapses with spike-timing dependent plasticity. *IEEE Trans. Neural Netw.* 17, 211–221. doi: 10.1109/TNN.2005.860850
- Jerry, M., Parihar, A., Grisafe, B., Raychowdhury, A., and Datta, S. (2017a). “Ultra-low power probabilistic imt neurons for stochastic sampling machines,” in *Proc. Symp. VLSI Technology* (Kyoto), T186–T187.
- Jerry, M., Parihar, A., Raychowdhury, A., and Datta, S. (2017b). “A random number generator based on insulator-to-metal electronic phase transitions,” in *Device Research Conference (DRC), 2017 75th Annual* (South Bend, IN), 1–2.
- Jerry, M., Shukla, N., Paik, H., Schlom, D. G., and Datta, S. (2016). “Dynamics of electrically driven sub-nanosecond switching in vanadium dioxide,” in *Silicon Nanoelectronics Workshop (SNW), 2016 IEEE* (Honolulu, HI), 26–27.
- Kar, A., Shukla, N., Freeman, E., Paik, H., Liu, H., Engel-Herbert, R., et al. (2013). Intrinsic electronic switching time in ultrathin epitaxial vanadium dioxide thin film. *Appl. Phys. Lett.* 102:072106. doi: 10.1063/1.4793537
- McKean, H. P. (1970). Nagumo’s equation. *Adv. Math.* 4, 209–223.
- Mehonic, A., and Kenyon, A. J. (2016). Emulating the electrical activity of the neuron using a silicon oxide rram cell. *Front. Neurosci.* 10:57. doi: 10.3389/fnins.2016.00057
- Parihar, A., Shukla, N., Datta, S., and Raychowdhury, A. (2015). Synchronization of pairwise-coupled, identical, relaxation oscillators based on metal-insulator phase transition devices: a model study. *J. Appl. Phys.* 117:054902. doi: 10.1063/1.4906783
- Pickett, M. D., Medeiros-Ribeiro, G., and Williams, R. S. (2013). A scalable neuristor built with mott memristors. *Nat. Mater.* 12, 114–117. doi: 10.1038/nmat3510
- Ricciardi, L. M., and Sato, S. (1988). First-passage-time density and moments of the ornstein-uhlenbeck process. *J. Appl. Probab.* 25, 43–57. doi: 10.2307/3214232
- Sengupta, A., Panda, P., Wijesinghe, P., Kim, Y., and Roy, K. (2016). Magnetic tunnel junction mimics stochastic cortical spiking neurons. *Sci. Rep.* 6:30039. doi: 10.1038/srep30039
- Shukla, N., Parihar, A., Cotter, M., Barth, M., Li, X., Chandramoorthy, N., et al. (2014a). “Pairwise coupled hybrid vanadium dioxide-MOSFET (HVFET) oscillators for non-boolean associative computing,” in *2014 IEEE International Electron Devices Meeting* (San Francisco, CA), 28.7.1–28.7.4.
- Shukla, N., Parihar, A., Freeman, E., Paik, H., Stone, G., Narayanan, V., et al. (2014b). Synchronized charge oscillations in correlated electron systems. *Sci. Rep.* 4:4964. doi: 10.1038/srep04964
- Tashman, J., Lee, J., Paik, H., Moyer, J., Misra, R., Mundy, J., et al. (2014). Epitaxial growth of VO₂ by periodic annealing. *Appl. Phys. Lett.* 104:063104. doi: 10.1063/1.4864404
- Tonnelier, A. (2003). The McKean’s caricature of the Fitzhugh–Nagumo Model I. The space-clamped system. *SIAM J. Appl. Math.* 63, 459–484. doi: 10.1137/S0036139901393500
- Tuma, T., Pantazi, A., Le Gallo, M., Sebastian, A., and Eleftheriou, E. (2016). Stochastic phase-change neurons. *Nat. Nanotechnol.* 11, 693–699. doi: 10.1038/nnano.2016.70
- Zhang, K., Wang, B., Wang, F., Han, Y., Jian, X., Zhang, H., et al. (2016). VO₂-based selection device for passive resistive random access memory application. *IEEE Elec. Dev. Lett.* 37, 978–981. doi: 10.1109/LED.2016.2582259

Conflict of Interest Statement: The authors declare that the research was conducted in the absence of any commercial or financial relationships that could be construed as a potential conflict of interest.

Copyright © 2018 Parihar, Jerry, Datta and Raychowdhury. This is an open-access article distributed under the terms of the Creative Commons Attribution License (CC BY). The use, distribution or reproduction in other forums is permitted, provided the original author(s) and the copyright owner are credited and that the original publication in this journal is cited, in accordance with accepted academic practice. No use, distribution or reproduction is permitted which does not comply with these terms.